

19th January 2024

GTE Exemption: No.F.4/1/2022-PPD-II

Global tender for CSAR photoresists

This is an RFQ (Request for Quote) for Supply of CSAR Photoresists to be used for Lithography in microelectronics applications (Quotes from global manufactures/vendors)

Procedure:

1. Indian agents should submit copy of Indian agent agreement/Authorization letter from OEM.
2. Either the Indian agent on behalf of Principal/OEM or Principal/OEM itself can bid but both cannot bid simultaneously for the same item.
3. Vendors are to register themselves at <https://hellovendor.iisc.ac.in>
4. The price of item quoted should be CIF Bangalore.
5. The technical description should take into account the following requirements and information that has been provided:

Chemical name	Make	Packing size (Quantity)
CSAR 6200.13	Allresist	250 ml (2)
CSAR 6200.09	Allresist	250 ml (2)
CSAR 6200.04	Allresist	250ml (2)
600- 546 Developer	Allresist	2.5 liter (1)

6. It is mandatory to specify the delivery period. Also, the manufacturing and expiry dates.
7. The materials will be used for high-tech research work by academic researchers. The vendor should have supplied the above material either to CeNSE, Indian Institute of



Science, Bangalore or other microelectronics fabrication unit of repute. Proof of the same should be attached.

8. CoA for the material quoted need to be attached with quotes
9. The deadline for submission of quotes is the 8th February 2024, 5:30 pm Indian Standard Time. Proposals should arrive sent before the above deadline.

Thanking you,

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